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PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | NISHIYAMA ET AL. | Examiner: | DOUG A. LE |
| Serial No.: | 10/506,730 | Group Art Unit: | 2818 |
| Filed: | SEPTEMBER 3, 2004 | Docket No.: | 12844.0084USWO |
| Title: | THIN FILM FORMING METHOD | | |

CERTIFICATE UNDER 37 CFR 1.6(d)

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on
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Dear Sir:

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Respectfully submitted,

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